

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wallace T.Y. Tang

Art Unit : Unknown

Serial No.: 09/909,766

Examiner: Unknown

Filed

: July 19, 2001

Title

: IN-SITU REAL-TIME MONITORING TECHNIQUE AND APPARATUS FOR

ENDPOINT DETECTION OF THIN FILMS DURING

CHEMICAL/MECHANICAL POLISHING PLANARIZATION

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed.

Under 35 USC §120, this application relies on the earlier filing date of application serial number 07/996,817, filed on December 28, 1992. The following references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application:

Desig. IDs:

AA-AF, AI, AK-AT, AW, AX, AZ-ABB, ADD, AFF, ATT, ACCC, ADDD, AFFF, ALLL, and AXXX.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1 8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231

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Carlos Brasil

Lyped or Printed Name of Person Signing Certificate

Applicant : Wallace T.Y. Tang

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Docket No.: 5353C2 459005

Respectfully submitted.

Date:

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